

C4.9 (R. Schuster)

- [C4.9:1] V. Halka, M.J. Schmid, V. Avrutskiy, X. Ma, and R. Schuster, *Electron-Beam-Induced Deposition of Metallic Microstructures from a Molten-Salt Film on Conductive and Nonconductive Substrates*, *Angew. Chem. Int. Ed.* **50**, 4692 (2011)